Question Paper Code: 50533

B.E. / B.Tech. DEGREE EXAMINATION, MAY 2017

Third Semester

Electronics and Instrumentation Engineering

15UEI303 - SENSORS AND TRANSDUCERS

(Common to Instrumentation and Control Engineering)

(Regulation 2015)

Duration: Three hours

Maximum: 100 Marks

Answer ALL Questions

PART A - (10 x 1 = 10 Marks)

- 1. The voltage of a circuit is measured by a voltmeter having an input impedance comparable with the output impedance of the circuit thereby causing error in voltage measurement. This error may be called
 - (a) Gross Error(b) Random Error(c) Error caused by misuse of instrument(d) Error caused by loading effect
- 2. Uncertainty distribution is used for
 - (a) analysis of multi-sample data
 - (b) analysis of single-sample data
 - (c) analysis of both single and multi sample data
 - (d) none of these
- 3. In measurement systems, which of the following static characteristics are desirable

(a) Accuracy	(b) Sensitivity	
(c) Reproducibility	(d) All of the above	

4. A pressure measurement instrument is calibrated between 10 bar and 250 bar. The scale span of the instrument is

(a) 10 bar	(b) 250 bar	(c) 240 bar	(d) 260 bar
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5. Dummy strain gauges are used for

- (a) Compensation of temperature changes
- (b) increasing the sensitivity of bridge in which they are included
- (c) compensating for different expansion
- (d) calibration of strain gauges
- 6. Thermocouples are
 - (a) Passive transducers (b) Active transducers
 - (c) Both active and passive transducers (d) Output transducers
- 7. In photo electric tachometer, the frequency at which these pulses are produced depends upon the number of holes in the disc and its speed of rotation
 - (a) number of teeth in the disc and its moment of inertia
 - (b) number of holes in the disc and its speed of rotation
 - (c) number of holes in the disc and its position
 - (d) none of these
- 8. SQUID stands for
 - (a) Superior Quality Interference Device
 - (b) Superconducting Quantum Interference Device
 - (c) Super Quality Intermediate Device
 - (d) None of these
- 9. Vibration is commonly expressed in
 - (a) Hertz (b) Volt (c) Ampere (d) Ohm
- 10. MEMS stands for
 - (a) Mechanical Electric Micro System
 - (b) Macro Electronic-Mechanical System
 - (c) Micro Electro-Mechanical System
 - (d) All the above

PART - B (5 x 2 = 10 Marks)

- 11. What do you mean by static calibration?
- 12. Differentiate range and span.
- 13. Mention two advantages of thermistors over resistance thermometers.
- 14. List out any four materials by which piezoelectric transducers are made off.

15. Draw the block diagram of the architecture of smart sensor.

PART - C (5 x 16 = 80 Marks)

16. (a) Explain in detail the various classifications of errors with examples and also discuss the methods of minimizing the errors. (16)

Or

- (b) Explain the criteria for selection of transducer for a particular application. (16)
- 17. (a) Derive the time response of a second order under damped measuring system for a unit step input. Draw the response. (16)

Or

- (b) Derive an equation for time response of a first order system when subjected to unit step input. Draw the response curves and find the dynamic errors. (16)
- 18. (a) Describe the construction of different types of strain gauges and working principle. (16)

Or

- (b) Describe in detail about variable reluctance transducer. (16)
- 19. (a) Describe the fiber optic sensor and its operation for temperature measurement. (16)

Or

- (b) Discuss the theory, working and application of Hall effect Transducer. (16)
- 20. (a) Explain in detail about the measurement of relative motion and absolute motion using seismic instruments. (16)

Or

(b) Describe the concepts and working of smart sensor with neat diagram. (16)